

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|--|---|------------------|---------|------------------|
| S1 | 2 | apparatus\$2 same (barrier near2 (layer or film)) same trench\$2 same (dielectric near2 (layer or film)) same ((ion near2 implant\$5) or dop\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2004/09/10 17:03 |
| S2 | 1107 | apparatus\$2 and (barrier near2 (layer or film)) and trench\$2 and (dielectric near2 (layer or film)) and ((ion near2 implant\$5) or dop\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/12 19:43 |
| S3 | 5 | apparatus\$2 same((barrier near2 (layer or film)) and trench\$2 and (dielectric near2 (layer or film)) and ((ion near2 implant\$5) or dop\$3)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2004/09/10 16:05 |
| S4 | 9 | ("5897368" "6110817" "6218303" "6239021" "6258695" "6300236" "6340633" "6342447" "6352938" "2001/0010401").PN. | USPAT | OR | OFF | 2004/09/10 16:07 |
| S5 | 1373 | apparatus\$2 near5 trench\$2 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2004/09/10 16:12 |
| S6 | 2500 | apparatus\$2 with trench\$2 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2004/09/10 16:12 |
| S7 | 62 | (apparatus\$2 with trench\$2) and (barrier near2 (layer or film)) and (dielectric near2 (layer or film))and ((ion near2 implant\$5) or dop\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2004/09/10 20:01 |
| S8 | 108 | isaac-stanetta.xa. | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2004/09/10 16:29 |
| S9 | 4 | "6713385" | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2004/09/10 17:04 |

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| S10 | 3043 | ((438/221) or (438/296) or (438/359) or (438/424) or (438/449) or (438/527) or (438/528)).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/08/08 09:16 |
| S11 | 4 | ((((438/221) or (438/296) or (438/359) or (438/424) or (438/449) or (438/527) or (438/528)).CCLS.) and (apparatus\$2 with trench\$2) and (barrier near2 (layer or film)) and (dielectric near2 (layer or film))and ((ion near2 implant\$5) or dop\$3)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2004/09/10 20:01 |
| S12 | 194 | apparatus same ((trench\$3 or groov\$3) near3 (silicon near2 (wafer\$1 or substrate\$1))) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 12:58 |
| S13 | 30 | S12 and (((ion near2 implant\$5) or dop\$3) same (dielectric or insulat\$3 or fill\$3)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 13:05 |
| S14 | 4230 | apparatus same (((ion near2 implant\$5) or dop\$3) same (dielectric or insulat\$3 or fill\$3)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 13:17 |
| S15 | 46 | S14 and ((trench\$3 or groov\$3) near3 (silicon near2 (wafer\$1 or substrate\$1))) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 13:09 |
| S16 | 2764 | ((((ion near2 implant\$5) or dop\$3) near3 (dielectric or insulat\$3 or fill\$3)) same (trench\$3 or groov\$3)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/08 09:45 |
| S17 | 383 | S16 and apparatus | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 13:19 |

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| S18 | 360 | S17 and semiconductor | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 13:20 |
| S19 | 1566 | ((ion near2 implant\$5) or dop\$3) near3 (dielectric or insulat\$3)) same (trench\$3 or groov\$3) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/08 13:39 |
| S20 | 232 | S19 and apparatus | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 13:21 |
| S21 | 221 | S20 and semiconductor | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 13:21 |
| S22 | 1161 | ((ion near2 implant\$5) or dop\$3) near3 ((dielectric or insulat\$3) near2 (layer\$1 or film\$1)) same (trench\$3 or groov\$3) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 15:22 |
| S23 | 154 | S22 and apparatus | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/04 15:23 |
| S24 | 3212 | ((438/221) or (438/296) or (438/359) or (438/424) or (438/449) or (438/527) or (438/528)).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/12/08 13:29 |
| S25 | 2089 | S24 and (trench\$2 or groov\$2) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/12 19:43 |
| S26 | 2021 | S25 and (((ion near2 implant\$5) or dop\$3) near5 ((trench\$2 or groov\$2) near2 fill\$3) or dielectric or insulat\$3 or fill\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/12 19:52 |

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| S27 | 1631 | S26 and (planar\$7 or (cmp or (chemical near2 polish\$3))) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/12 19:49 |
| S28 | 367 | S27 and nitrogen | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/12 19:50 |
| S29 | 2021 | S25 and (((ion near2 implant\$5) or dop\$3) near ((trench\$2 or groov\$2) near2 fill\$3) or dielectric or insulat\$3 or fill\$3) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/01/12 19:52 |
| S30 | 3301 | ((438/221) or (438/296) or (438/359) or (438/424) or (438/449) or (438/527) or (438/528)).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/03/18 11:45 |
| S31 | 24 | S30 and ((ion\$1 or (ion near implant\$5) or dop\$3) near3 ((dielectric or insulat\$3) near2 (trench\$2 or groov\$2 or aperture\$1))) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/03/18 11:48 |
| S32 | 3516 | ((438/221) or (438/296) or (438/359) or (438/424) or (438/449) or (438/527) or (438/528)).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/08/08 09:16 |
| S33 | 3082 | ((ion near2 implant\$5) or dop\$3) near3 (dielectric or insulat\$3 or fill\$3) same (trench\$3 or groov\$3) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/08 09:45 |
| S34 | 146 | S32 and S33 | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/08 09:45 |
| S35 | 13 | S34 and ((high\$3 or increas\$3) near2 etch\$3 near rate) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/08/08 09:46 |

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|-----|-------|---|---|----|-----|------------------|
| S36 | 7024 | ((438/221) or (438/296) or (438/359) or (438/423) or (438/424) or (438/433) or (438/449) or (438/527) or (438/528) or (438/692) or (438/700)).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/12/08 13:38 |
| S37 | 144 | S36 and (((ion near2 implant\$5) or dop\$3) near3 (dielectric or insulat\$3)) same (trench\$3 or groov\$3)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/08 13:46 |
| S38 | 234 | S36 and (((ion near2 implant\$5) or dop\$3) near3 (dielectric or insulat\$3 or fill\$3)) same (trench\$3 or groov\$3)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/08 13:46 |
| S39 | 16205 | "10" and (("CMP" or planar\$7) near5 (trench\$2 or groove\$1)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/08 13:47 |
| S40 | 97 | S38 and (("CMP" or planar\$7) near5 (trench\$2 or groove\$1)) | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/12/08 13:47 |

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| S41 | 108 | ("3629023" "3979239" "4010583" "4193226" "4256535" "4261791" "4373991" "4393628" "4505720" "4600469" "4677043" "4768883" "4778532" "4789648" "4811522" "4879258" "4933715" "4944836" "4954141" "4956313" "4962423" "4968381" "4986878" "5032203" "5057462" "5064683" "5084419" "5209816" "5262354" "5273558" "5288333" "5294570" "5312777" "5320706" "5320978" "5340370" "5346584" "5362668" "5362669" "5363550" "5376482" "5389194" "5389579" "5392361" "5395801" "5397741" "5401691" "5406111" "5421769" "5435772" "5436488" "5441094" "5453639" "5459096" "5468983" "5486265" "5492858" "5494857" "5503962" "5525840" "5531861" "5541427" "5551986" "5573633" "5578523" "5591239" "5595937" "5602423" "5607345" "5616513" "5629242" "5643406" "5643823" "5643836" "5652176" "5656097" "5662769" "5664990" "5665202" "5666985" "5676587" "5695572" "5702977" "5721172" "5728308" "5776808" "5782675" "5786260" "5837612" "5906532" "5919082" "5928959" "5943590" "5952687" "5963841" "5972124" "5972792" "6010964" "6016000" "6042996" "6063689" "6136713" "6143663" "6200896" "6218267" "6227956" "6265315" "6435944").PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2005/12/08 13:48 |
| S42 | 0 | ("6969684").URPN. | USPAT | OR | OFF | 2005/12/08 13:51 |

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| S43 | 2 | ("6514833" "6576558").PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2005/12/08 13:52 |
| S44 | 24 | ("4577395" "4589193" "4654120" "4722910" "5021355" "5059550" "5212106" "5215937" "5229316" "5258332" "5275965" "5281550" "5292683" "5298110" "5300447" "5396096" "5408116" "5413945" "5482878" "5506168" "5521422" "5607875" "5677229" "5741738").PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2005/12/08 13:56 |
| S45 | 11 | ("6084276").URPN. | USPAT | OR | OFF | 2005/12/08 13:58 |
| S46 | 3 | ("4571819" "5316965" "5616513").PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2005/12/08 14:01 |
| S47 | 15 | ("5902127").URPN. | USPAT | OR | OFF | 2005/12/08 15:08 |
| S48 | 249 | (438/433).CCLS. | US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB | OR | OFF | 2005/12/08 15:09 |
| S49 | 3 | ("20020098661" "20020137306" "6221734").PN. | US-PGPUB; USPAT; USOCR | OR | OFF | 2005/12/08 15:13 |